



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

C. Moore

PATCH P-1903 Policiti

NAGAHAMA et al

Atty. Ref.: 925-179

Serial No. 09/500,288

Group: 2814

Filed: February 8, 2000

Examiner: Louie

For: NITRIDE SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD

\* \* \* \* \* \* \* \* \* \*

June 13, 2003

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## AMENDMENT AFTER FINAL REJECTION

Responsive to the Official Action dated March 31, 2003, please amend the above-identified application as follows:

TECHMOLOGY CENTER 2000